

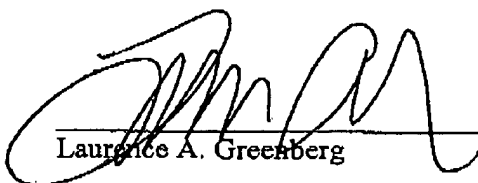
Docket No.: P2001,0128

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/635,583
Inventor : Heiko Hommen et al.
Filed : August 6, 2003
Title : Method for Exposing at Least One or at Least Two Semiconductor Wafers
TC/A.U. : 1756
Examiner : Christopher G. Young
Customer No.: 24131

Declaration

I, Laurence A. Greenberg, the attorney of record in the above-identified application, herewith state that a thorough search of counsel's Office records (data base and mail docket) reveals that no Office action dated February 9, 2004 has been received by counsel, and that, therefore, no reply was filed by the due date of May 9, 2004



Laurence A. Greenberg

LAURENCE A. GREENBERG
REG. NO. 29,308

Date: February 4, 2005